



## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroaki TAKAIWA et al.

Group Art Unit: 2851

Application No.: 10/587,268

Examiner:

M. LIU

Filed: July 26, 2006

Docket No.:

128865

For:

IMMERSION EXPOSURE APPARATUS AND DEVICE MANUFACTURING

METHOD WITH LIQUID DETECTION APPARATUS (AS AMENDED)

## <u>AMENDMENT</u>

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In reply to the June 25, 2008 Office Action, the shortened statutory period for reply being extended by the attached Petition for Extension of Time, please consider the following:

Amendments to the Specification;

Amendments to the Claims as reflected in the listing of claims; and

Remarks.